

<b>INFORMATION DISCLOSURE CITATION FORM FOR PATENT APPLICATION (FORM PTO-1449) (Substitute)</b>		Docket No. 02W155.  Applicant(s): Kennedy et al.  Filing Date: Herewith  Serial No.:  Group:			
<b>U.S. PATENT DOCUMENTS</b>					
Examiner Initials	Document Number (Number-Kind Code)	Publication Date (MM-DD-YYYY)	Name of Patentee or Applicant	Class	Sub-class
WJ  	US-6,326,611	12-04-2001	Kennedy et al.	250	239
	US-6,122,919	09-26-2000	Patel et al.	62	51.1
	US-6,077,046	06-20-2000	Kennedy et al.	417	48
	US-6,043,982	03-28-2000	Meissner	361	704
	US-5,921,461	07-13-1999	Kennedy et al.	228	124.6
	US-5,808,350	09-15-1998	Jack et al.	257	440
	US-5,708,269	01-13-1998	Meissner et al.	350	332
	US-5,688,699	11-18-1997	Cunningham et al.	437	3
	US-5,399,897	3-21-1995	Cunningham et al.	257	467
	US-5,895,233	4-20-1999	Higashi et al.	407	107
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<b>FOREIGN PATENT DOCUMENTS</b>					
Examiner Initials	Document Number (Country Code-Number-Kind Code)	Publication Date (MM-DD-YYYY)	Name Of Patentee of Applicant	Translation? Yes/No/n/a	
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<b>OTHER DOCUMENTS (Author (Capitalize), Title, Date, Pages, Etc., if known)</b>					
"Fluxless High-Vacuum Packaging of MEMS and IR Sensors", SST International, September 2002.					
Examiner's Signature: <i>Viktor Tish</i>			Date Considered: <i>8/18/05</i>		
Initial if reference was considered, whether or not citation is in conformance with MPEP. Mark through citation if not considered. Include a copy of this citation form with your next correspondence to the Applicant(s).					